## **GROUP 1700**

MAY 1 0 2003

## RECEIVED

500.39825X00

## NITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

T. HIROSE, et al.

Serial No.:

09/800,495

Filed:

March 8, 2001

For:

METHOD OF DETECTING AND MEASURING ENDPOINT OF

POLISHING PROCESSING AND ITS APPARATUS AND

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

**USING THE SAME** 

Group:

1765

Examiner:

L. Umez Eronini

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

May 15, 2003

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the first month subsequent to the shortened statutory period set in the outstanding Office Action mailed January 15, 2003. A payment in the amount of \$110.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (500.39825X00).

Respectfully submitted,

05/16/2003 SDENBOB1 00000040 09800495

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110.00 OP

Registration No. 22,466

ANTONELLI, TERRY, STOUT & KRAUS, LLP

MK/cee

(703) 312-6600